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Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. GK-OEH-173 / 500814.20075

Applicant(s): Guido SCHRIEVER; Kai GAEBEL; and Uwe STAMM

Application No.: 10/697,579

Filed: October 30, 2003 Group: 2878

For: RADIATION SOURCE FOR GENERATING EXTREME ULTRAVIOLET RADIATION

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**S U P P L E M E N T A L
INFORMATION DISCLOSURE STATEMENT**

SIR:

Supplemental to the information Disclosure Statement filed on October 30, 2003, applicants submits a copy of document AP and an English Abstract PREVIOUSLY OMITTED.

	Document Number	Date	Name and/or Country	English Translation
AP	102 37 901.7	08/16/2002	Germany	Abstract only

Accompanying this Supplemental Information Disclosure Statement is a copy of the originally submitted form PTO-1449.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

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Enclosures:

PTO-1449,
DE doc.
& English Abstract



LIST OF PRIOR ART CITED BY APPLICANT
(Filed on October 30, 2003)

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Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	5,991,360	11/23/1999	Matsui, et al.			
	AB	6,002,744	12/14/1999	Hertz, et al.			
	AC	6,018,537	01/25/2000	Hofmann, et al.			
	AD	6,304,630	10/16/2001	Bisschops, et al.			
	AE	2002/0094063 A1	07/18/2002	Nishimura, et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES NO
	AL	39 27 089	04/25/1991	Germany			Abstract only
	AM	1 109 427	06/20/2001	European			
	AN	1 170 892	01/09/2002	European			
	AO	102 15 469.4	04/05/2002	Germany			10/407,394
	AP	102 37 901.7	08/16/2002	Germany			Abstract only
	AQ						
	AR						
	AS						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AV	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.